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Journal of Photochemistry Photobiology A:Chemistry

Journal of Photochemistry and Photobiology A: Chemistry 182 (2006) 220–224

www.elsevier.com/locate/jphotochem

Generation of optical-field controlled high-intensity laser pulses

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Available online 11 July 2006

Abstract

We demonstrated control of electric fields of optical pulses by combining the pulse shaper with carrier-envelope phase (CEP) stabilized lasers. We employed spectral phase controller known as the pulse shaper for controlling the pulse envelope and the CEP. In order to evaluate the accuracy of the device, we measured the CEP shift, and delay shift by the spectral interferometry method and confirmed that the CEP and the delay were precisely controlled by the pulse shaper independently. We demonstrated control of the CEP and the relative spectral phase of amplified high-intensity laser pulses by installing the pulse shaper in a CEP stabilized amplifier system. The pulse shaper worked as an ideal CEP shifter because it controlled the phase of very broad spectrum precisely, and independent control of CEP was achieved. © 2006 Elsevier B.V. All rights reserved.

Keywords: Femtosecond lasers; Carrier-envelope phase; Pulse shaping; High-intensity lasers

1. Introduction

The carrier-envelope phase (CEP) is the relative phase between the peak of the pulse envelope and the electric field. Recently, methods to control the pulse-to-pulse shift of the carrier-envelope phase that is called carrier-envelope offset (CEO) phase, have been demonstrated [\[1,2\].](#page--1-0) These results opened a way to control the electric-field shape of optical pulses. Such laser sources are important for the metrology as well as for controlling laser–matter interactions. Using a carrier-envelope offset (CEO) phase stabilized few-cycle laser oscillator, dependence of the photoelectron emission on the CEP was investigated [\[3\].](#page--1-0) Furthermore, using CEP stabilized amplified laser pulses, control of high-order harmonic generation and attosecond pulse measurement were demonstrated [\[4,5\], a](#page--1-0)nd measurement of the electric field of optical pulse was demonstrated using the attosecond pulses [\[6\].](#page--1-0)

CEP stabilization in an amplified laser system was demonstrated in a chirped-pulse amplification (CPA) system composed of a material-based pulse stretcher and a prism-based pulse compressor [\[4\],](#page--1-0) and in a commonly used CPA system employing grating-based stretcher/compressor and regenerative/multi-pass amplifiers [\[7\]. T](#page--1-0)here are also passive CEP stabilization schemes

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using an optical parametric amplifier [\[8\]](#page--1-0) or a difference fre-quency generation scheme [\[9\].](#page--1-0)

If one assumes a pump-probe experiment with CEP stabilized pulses, one has to prepare a set of pulses, one has fixed CEP and the other has controllable CEP without shifting the relative delay and without changing the pulse envelope shape. A CEP shifter that controls only the CEP will be required. The wellknown easiest way to control the CEP of a pulse is to change the optical path length in a dispersive material. A thin plate, however, shifts the relative delay of the pulse and it will change the pulse envelope shape for a very broad spectrum due to the group velocity dispersion [\[10\].](#page--1-0)

The pulse-shaping technique [\[11\]](#page--1-0) that controls the relative spectral phase allows us to control the shape of the pulse envelope. The technique has been widely used to compensate for the residual dispersion [\[12\], t](#page--1-0)o optimize the laser–matter interaction [\[13\],](#page--1-0) and to control spectral distribution of HHG [\[14\].](#page--1-0) In these experiments, however, the relative phase between the pulse envelope and the carrier field was not stabilized. The shape of the pulse envelope was controlled precisely, however, the electric field inside the pulse envelope was not stabilized. If we apply the pulse-shaping technique for the CEP stabilized pulses, we can fully control the electric field shape of pulses. We proposed and demonstrated an active CEP-shifting device employing a pulse shaper, which is an active CEP shifter with a calibrated phase shift that can shift the CEP without affecting the delay and the shape of the pulse envelope [\[15,16\].](#page--1-0) We here report a

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Fig. 1. Relation between the spectral phase and the carrier-envelope phase and delay.

chirped-pulse amplification system providing electric-field controlled optical pulses by combining the CEP stabilized laser system with the pulse shaping devices that works not only as a pulse envelope shaper but also as a CEP shifter.

2. Theory

Fig. 1 schematically shows the relation between the spectral phase and the CEP and the time delay. The left shows the spectral phase as a function of the angular frequency and the right shows the optical waveforms in time domain. We here assume a transform-limited pulse that has a flat spectral phase (constant value or a linear function of the frequency). In the spectral domain, the CEP is defined as the intercept of the spectral phase at zero frequency, and the slope of the spectral phase corresponds to the delay of the pulse [\[17\]. A](#page--1-0)n ideal CEP shifter that shift only the CEP without changing the pulse timing (delay) and the pulse envelope should give constant phase shift to all the frequency component.

In some experiments, insertion of dispersive material into the beam path is used as CEP shifting method. The dispersive material gives both the delay shift and the phase shift to the pulse. Because the delay shift is determined by the group velocity and the phase shift is determined by the phase velocity, propagation by $L = 1/(dn/d\lambda)$ results in CEP shift of 2π from the difference of the two velocities. For example, propagation of $L = 1/(dn/d\lambda) = 58 \mu m$ for fused-silica plate at 800 nm. This method is easy and work well for 10 fs pulses around 800 nm, however, for pulses having much broader spectrum, the effect of the higher-order term of the spectral phase can not be neglected. The higher-order term changes the pulse envelope shape and will result in error in the CEP shift [\[10\]. T](#page--1-0)he method using the pulse shaper can control the phase of a broad spectrum [\[12\], t](#page--1-0)herefore, it can be an ideal CEP shifter.

The schematic of the optical-field controlled laser system is shown in Fig. 2, which is a combination of a CEP stabilized laser and a pulse shaper. Such system allows us to control both the optical phase inside the pulse envelope and the shape of the pulse envelope.

3. Experimental

The pulse shaper is composed of a liquid-crystal spatial light modulator (SLM, SLM-S640/12 Jenoptic) placed at the Fourier transform plane of a 4*f* optical configuration, two cylindrical mirrors $(f = 224 \text{ mm})$, two prisms (SFL03) and folding mirrors as shown in Fig. 2. [Fig. 3](#page--1-0) shows the diagram of the laser system. We installed the pulse shaper in a CEP stabilized CPA system [\[7\].](#page--1-0) The amplifier system is composed of a CEO stabilized oscillator, a pulse-selection system, a grating-based pulse stretcher, a regenerative amplifier, a multi-pass amplifier, and a grating-based pulse compressor. The CEO beat frequency *f*_{ceo} was stabilized to $f_{\text{osc}}/8$ with phase-locked-loop electronics. The pulses possessing the same CEP are selected by a Pockels cell in the regenerative amplifier. The pulse energy is 3.5 mJ after the four-pass amplifier, and the compressed pulse is about 1 mJ.

Fig. 2. Schematic of the laser system generating optical-field controlled pulses.

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